- SUBSTRATE **UV GRADE FUSED SILICA**
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 ARCSEC
- 3. COATING (APPLY ACROSS COATING APERTURE)

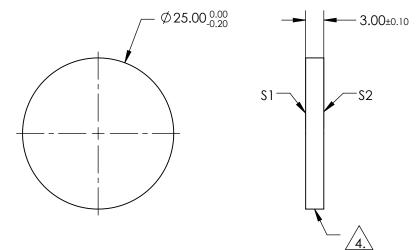
PERFORMANCE SPECIFICATIONS @ 0° AOI T(AVG): >85% FROM 420 - 2000nm T(AVG): < 1% FROM 200 - 375nm

T(ABS): = 50% @ 400nm

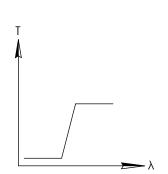
\$1: MULTILAYER DIELECTRIC COATING \$2: SINGLE LAYER MgF2

4.\ FINE GRIND SURFACE

- 5. TRANSMITTED WAVEFRONT DISTORTION RMS@ 632.8nm ≤ 1/4 WAVE
- 6. ROHS COMPLIANT



PARTS TO THIS DRAWING



LONGPASS FILTER

	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	80%	80%
COATING APERTURE	Ø20.00	Ø20.00
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

			B Edmund Optics®	
THIRD ANGLE PROJECTION	\bigoplus	TITLE	OD2, Ø25mm, 400nm LONGPASS FIL	TER
ALL DIMS IN	mm	DWG NO	47614	SHEET 1 OF 1

- SUBSTRATE **UV GRADE FUSED SILICA**
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 ARCSEC
- 3. COATING (APPLY ACROSS COATING APERTURE)

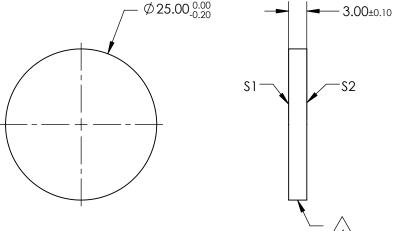
PERFORMANCE SPECIFICATIONS @ 0° AOI T(AVG): >85% FROM 470 - 2000nm T(AVG): < 1% FROM 200 - 430nm

T(ABS): = 50% @ 450nm

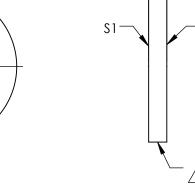
\$1: MULTILAYER DIELECTRIC COATING \$2: SINGLE LAYER MgF2

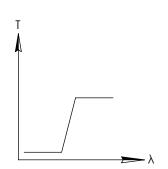
4.\ FINE GRIND SURFACE

- 5. TRANSMITTED WAVEFRONT DISTORTION RMS@ 632.8nm ≤ 1/4 WAVE
- 6. ROHS COMPLIANT



PARTS TO THIS DRAWING





LONGPASS FILTER

BEVEL

	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	80%	80%
COATING APERTURE	Ø20.00	Ø20.00

PROTECTIVE AS NEEDED | PROTECTIVE AS NEEDED

			Edmund Optics®	
THIRD AND	SLE ON	TITLE	OD2, Ø25mm, 450nm LONGPASS FIL	TER
ALL DIMS	N mm	DWG NO	47615	SHEET 1 OF 1

- SUBSTRATE
 UV GRADE FUSED SILICA
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 ARCSEC
- 3. COATING (APPLY ACROSS COATING APERTURE)

PERFORMANCE SPECIFICATIONS @ 0° AOI T(AVG): >85% FROM 520 - 2000nm T(AVG): < 1% FROM 200 - 480nm

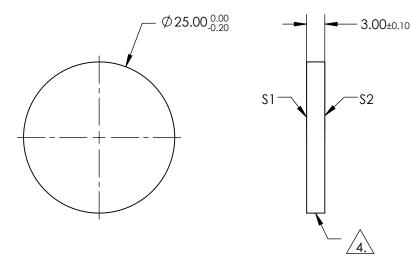
T(ABS): = 50% @ 500nm

\$1: MULTILAYER DIELECTRIC COATING

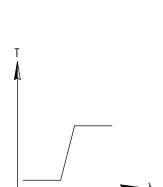
S2: SINGLE LAYER MgF2

4. FINE GRIND SURFACE

- 5. TRANSMITTED WAVEFRONT DISTORTION RMS@ 632.8nm ≤ 1/4 WAVE
- 6. ROHS COMPLIANT

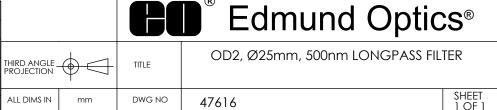


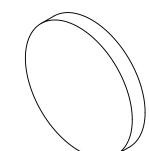
PARTS TO THIS DRAWING



LONGPASS FILTER

	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	80%	80%
COATING APERTURE	Ø20.00	Ø20.00
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED





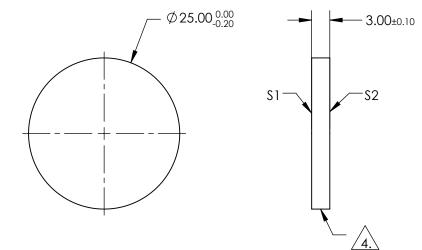
- SUBSTRATE UV GRADE FUSED SILICA
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 ARCSEC
- 3. COATING (APPLY ACROSS COATING APERTURE)

PERFORMANCE SPECIFICATIONS @ 0° AOI T(AVG): >85% FROM 575 - 2000nm T(AVG): < 1% FROM 415 - 515nm T(ABS): = 50% @ 550nm

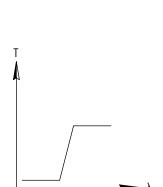
\$1: MULTILAYER DIELECTRIC COATING \$2: SINGLE LAYER MgF2

4.\ FINE GRIND SURFACE

- 5. TRANSMITTED WAVEFRONT DISTORTION RMS@ 632.8nm ≤ 1/4 WAVE
- 6. ROHS COMPLIANT



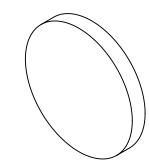
PARTS TO THIS DRAWING



LONGPASS FILTER

	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	80%	80%
COATING APERTURE	Ø20.00	Ø20.00
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

			Edmund Optics®	
THIRD ANGLE PROJECTION	\rightarrow	TITLE	OD2, Ø25mm, 550nm LONGPASS FIL	TER
ALL DIMS IN	mm	DWG NO	47617	SHEET 1 OF 1



- SUBSTRATE
 UV GRADE FUSED SILICA
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 ARCSEC
- 3. COATING (APPLY ACROSS COATING APERTURE)

PERFORMANCE SPECIFICATIONS @ 0° AOI T(AVG): >85% FROM 625 - 2000nm T(AVG): < 1% FROM 460 - 570nm

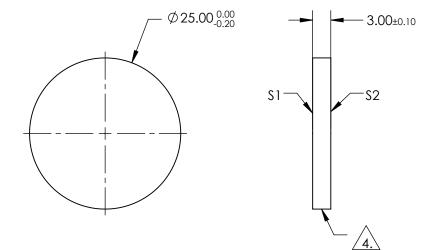
T(ABS): = 50% @ 600nm

\$1: MULTILAYER DIELECTRIC COATING

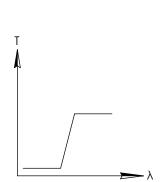
S2: SINGLE LAYER MgF2

4. FINE GRIND SURFACE

- 5. TRANSMITTED WAVEFRONT DISTORTION RMS@ 632.8nm ≤ 1/4 WAVE
- 6. ROHS COMPLIANT

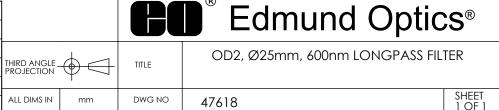


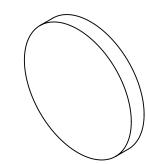
PARTS TO THIS DRAWING



LONGPASS FILTER

	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	80%	80%
COATING APERTURE	Ø20.00	Ø20.00
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED





- SUBSTRATE **UV GRADE FUSED SILICA**
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 ARCSEC
- 3. COATING (APPLY ACROSS COATING APERTURE)

PERFORMANCE SPECIFICATIONS @ 0° AOI T(AVG): >85% FROM 675 - 2000nm T(AVG): < 1% FROM 495 - 610nm

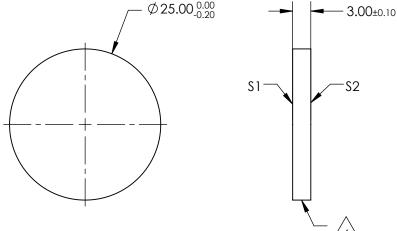
T(ABS): = 50% @ 650nm

\$1: MULTILAYER DIELECTRIC COATING

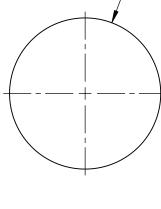
S2: SINGLE LAYER MgF2

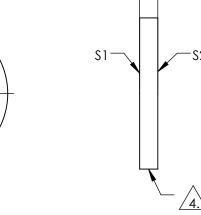
4.\ FINE GRIND SURFACE

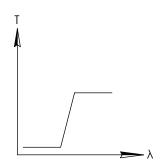
- 5. TRANSMITTED WAVEFRONT DISTORTION RMS@ 632.8nm ≤ 1/4 WAVE
- 6. ROHS COMPLIANT



PARTS TO THIS DRAWING

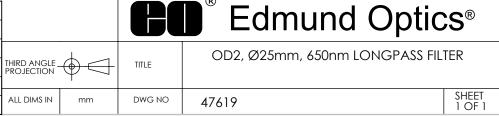






LONGPASS FILTER

	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	80%	80%
COATING APERTURE	Ø20.00	Ø20.00
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED



- SUBSTRATE
 UV GRADE FUSED SILICA
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 ARCSEC
- 3. COATING (APPLY ACROSS COATING APERTURE)

PERFORMANCE SPECIFICATIONS @ 0° AOI T(AVG): >85% FROM 775 - 2000nm T(AVG): < 1% FROM 535 - 660nm

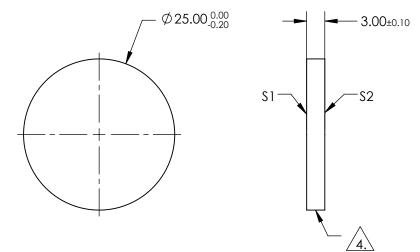
T(ABS): = 50% @ 700nm

\$1: MULTILAYER DIELECTRIC COATING

S2: SINGLE LAYER MgF2

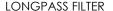
4. FINE GRIND SURFACE

- 5. TRANSMITTED WAVEFRONT DISTORTION RMS@ 632.8nm ≤ 1/4 WAVE
- 6. ROHS COMPLIANT

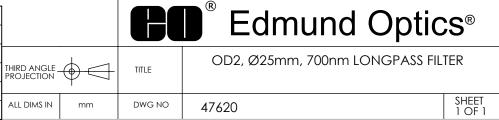


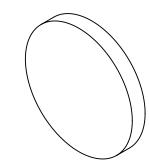
PARTS TO THIS DRAWING





	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	80%	80%
COATING APERTURE	Ø20.00	Ø20.00
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED





- SUBSTRATE
 UV GRADE FUSED SILICA
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 ARCSEC
- 3. COATING (APPLY ACROSS COATING APERTURE)

PERFORMANCE SPECIFICATIONS @ 0° AOI T(AVG): >85% FROM 445 - 2000nm T(AVG): < 1% FROM 200 - 405nm

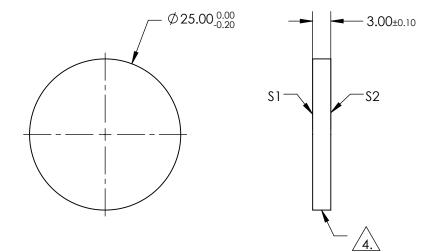
T(ABS): = 50% @ 425nm

\$1: MULTILAYER DIELECTRIC COATING

S2: SINGLE LAYER MgF2

4. FINE GRIND SURFACE

- 5. TRANSMITTED WAVEFRONT DISTORTION RMS@ 632.8nm ≤ 1/4 WAVE
- 6. ROHS COMPLIANT

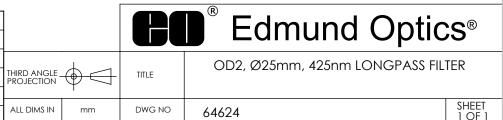


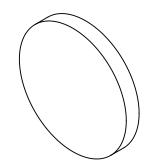
PARTS TO THIS DRAWING





	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	80%	80%
COATING APERTURE	Ø20.00	Ø20.00
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED





- SUBSTRATE
 UV GRADE FUSED SILICA
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 ARCSEC
- 3. COATING (APPLY ACROSS COATING APERTURE)

PERFORMANCE SPECIFICATIONS @ 0° AOI T(AVG): >85% FROM 495 - 2000nm T(AVG): < 1% FROM 200 - 455nm

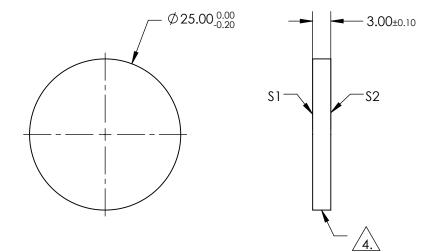
T(ABS): = 50% @ 475nm

\$1: MULTILAYER DIELECTRIC COATING

S2: SINGLE LAYER MgF2

4. FINE GRIND SURFACE

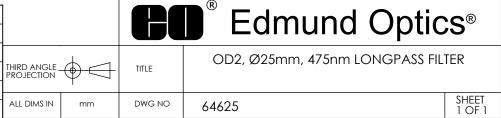
- 5. TRANSMITTED WAVEFRONT DISTORTION RMS@ 632.8nm ≤ 1/4 WAVE
- 6. ROHS COMPLIANT



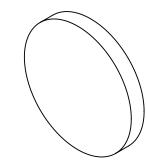




	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	80%	80%
COATING APERTURE	Ø20.00	Ø20.00
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED







- SUBSTRATE
 UV GRADE FUSED SILICA
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 ARCSEC
- 3. COATING (APPLY ACROSS COATING APERTURE)

PERFORMANCE SPECIFICATIONS @ 0° AOI T(AVG): >85% FROM 545 - 2000nm T(AVG): < 1% FROM 200 - 505nm

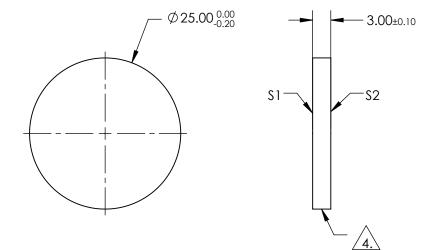
T(ABS): = 50% @ 525nm

\$1: MULTILAYER DIELECTRIC COATING

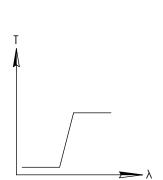
S2: SINGLE LAYER MgF2

4. FINE GRIND SURFACE

- 5. TRANSMITTED WAVEFRONT DISTORTION RMS@ 632.8nm ≤ 1/4 WAVE
- 6. ROHS COMPLIANT

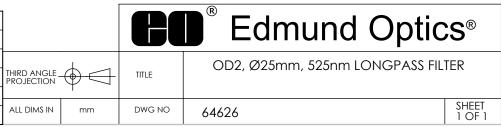


PARTS TO THIS DRAWING



LONGPASS FILTER

	\$1	\$2	
SHAPE	PLANO	PLANO	
SURFACE QUALITY	40-20	40-20	
CLEAR APERTURE	80%	80%	
COATING APERTURE	Ø20.00	Ø20.00	
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	





- SUBSTRATE
 UV GRADE FUSED SILICA
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 ARCSEC
- 3. COATING (APPLY ACROSS COATING APERTURE)

PERFORMANCE SPECIFICATIONS @ 0° AOI T(AVG): >85% FROM 600 - 2000nm T(AVG): < 1% FROM 440 - 540nm

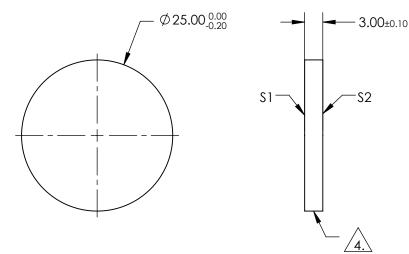
T(ABS): = 50% @ 575nm

\$1: MULTILAYER DIELECTRIC COATING

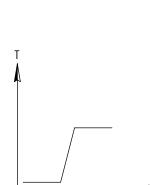
S2: SINGLE LAYER MgF2

4. FINE GRIND SURFACE

- 5. TRANSMITTED WAVEFRONT DISTORTION RMS@ 632.8nm ≤ 1/4 WAVE
- 6. ROHS COMPLIANT

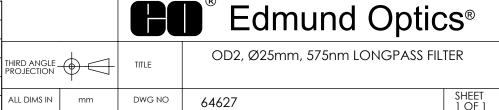


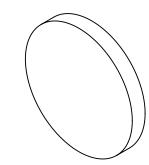
PARTS TO THIS DRAWING



LONGPASS FILTER

	\$1	S2	
SHAPE	PLANO	PLANO	
SURFACE QUALITY	40-20	40-20	
CLEAR APERTURE	80%	80%	
COATING APERTURE	Ø20.00	Ø20.00	
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	





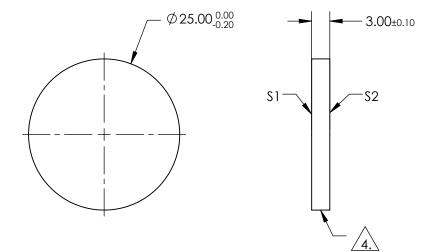
- SUBSTRATE
 - UV GRADE FUSED SILICA
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 ARCSEC
- 3. COATING (APPLY ACROSS COATING APERTURE)

PERFORMANCE SPECIFICATIONS @ 0° AOI T(AVG): >85% FROM 650 - 2000nm T(AVG): < 1% FROM 485 - 595nm T(ABS): = 50% @ 625nm

\$1: MULTILAYER DIELECTRIC COATING \$2: SINGLE LAYER MgF2

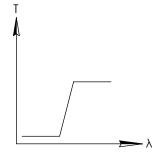
4.\ FINE GRIND SURFACE

- 5. TRANSMITTED WAVEFRONT DISTORTION RMS@ 632.8nm ≤ 1/4 WAVE
- 6. ROHS COMPLIANT



PARTS TO THIS DRAWING

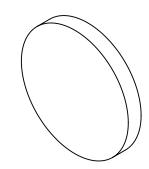




LONGPASS FILTER

	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	80%	80%
COATING APERTURE	Ø20.00	Ø20.00
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

			Edmund Optics®	
THIRD ANGLE PROJECTION		TITLE	OD2, Ø25mm, 625nm LONGPASS FIL	TER
ALL DIMS IN	mm	DWG NO	64628	SHEET 1 OF 1



- SUBSTRATE UV GRADE FUSED SILICA
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 ARCSEC
- 3. COATING (APPLY ACROSS COATING APERTURE)

PERFORMANCE SPECIFICATIONS @ 0° AOI T(AVG): >85% FROM 700 - 2000nm T(AVG): < 1% FROM 520 - 635nm

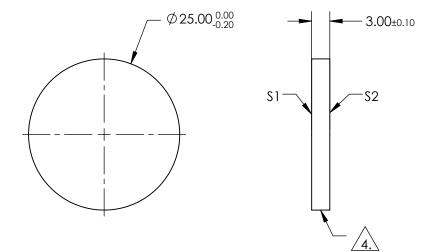
T(ABS): = 50% @ 675nm

\$1: MULTILAYER DIELECTRIC COATING

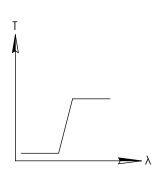
S2: SINGLE LAYER MgF2

4.\ FINE GRIND SURFACE

- 5. TRANSMITTED WAVEFRONT DISTORTION RMS@ 632.8nm ≤ 1/4 WAVE
- 6. ROHS COMPLIANT



PARTS TO THIS DRAWING



LONGPASS FILTER

	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	80%	80%
COATING APERTURE	Ø20.00	Ø20.00
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE DIMENSIONS ARE FOR REFERENCE ONLY

1 OF 1

